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## BIB DATA SHEET

CONFIRMATION NO. 7978

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/550,365	06/14/2006	438	1792	23390
<b>APPLICANTS</b> Hilde Hardtdegen, Aachen, GERMANY; Roland Schmidt, Übach-Palenberg, GERMANY; Nicoleta Kaluza, Mönchengladbach, GERMANY; Konrad Wirtz, Baesweiler, GERMANY; Yuri Makarov, Erlangen, GERMANY;				
<b>** CONTINUING DATA ***** Yes FPS</b> This application is a 371 of PCT/DE04/00315 02/20/2004				
<b>** FOREIGN APPLICATIONS ***** Yes FPS</b> GERMANY 103 12 768.2 03/21/2003 GERMANY 103 25 629.6 06/06/2003				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 11/02/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/FRANCIS P SMITH/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> GERMANY	<b>SHEETS DRAWINGS</b> 5	<b>TOTAL CLAIMS</b> 17
<b>INDEPENDENT CLAIMS</b> 2				
<b>ADDRESS</b> K.F. ROSS P.C. 5683 RIVERDALE AVENUE SUITE 203 BOX 900 BRONX, NY 10471-0900 UNITED STATES				
<b>TITLE</b> Method for depositing compounds on a substrate by means of metalorganic chemical vapor deposition				
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	